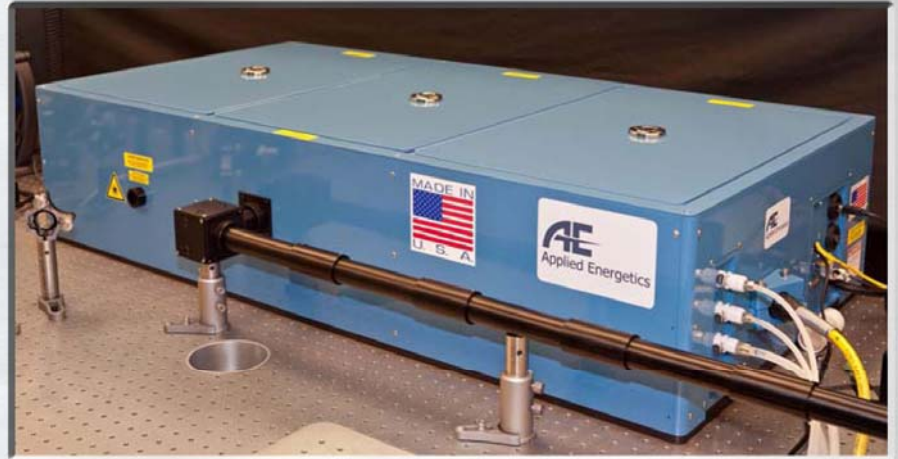


Leopard Ultra Fast Laser Amplifier

Applications

This high power ultra-fast amplifier can be used in a variety of industrial applications and configured for in-line processing as a complete solution with material-handling equipment as required.

- Micro-machining
- Photomask repair
- Thin film scribing
- Time-resolved spectroscopy
- Biological diagnostics
- Defense
- Laser R&D



Performance

Gain media	Yb:YAG Thin Disk, 1031 nm center wavelength
High Output Power	> 100 W (1 W input at 30MHz, gain = 100, non-CPA operation)
High Pulse Energy Gain	> 40,000 (400 μ J/pulse at 10 nJ/pulse input at 1kHz)
Compressed Pulse Width	< 1.0 ps
System includes on-board stretcher and compressor	
System designed for use with Applied Energetics Ocelot Laser oscillator	

Options

- Motor Controlled Adjustable Compression (compressed pulse length 0.8 ps to 8 ps)
- System without Stretcher and Compressor (for low pulse energy operation)
- Remote pico-mirror adjustment control
- Motor controlled OAP position
- Camera monitors of OAP/Disk
- Saturable Absorber (for low repetition rate operation)
- Chiller, OptiTemp OCT-1.0A

Leopard Ultra Fast Laser Amplifier

Electrical Requirements:

230 VAC, single phase, 30 Amp service (for pump laser & chiller)
 115 VAC, single phase, 15 Amp service for controls

Mechanical:

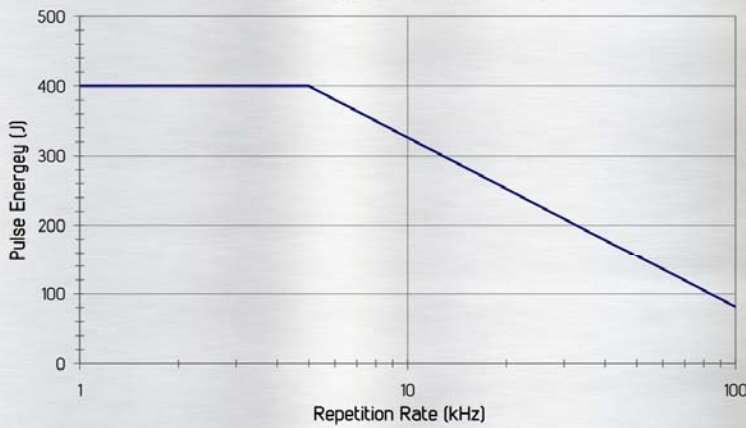
Leopard Amplifier Enclosure
Control Rack (19")

48"x24"x10³/₄" length, width, height
 5 foot (1.5m) high rack includes the Diode Pump & Driver
 and space for the control computer

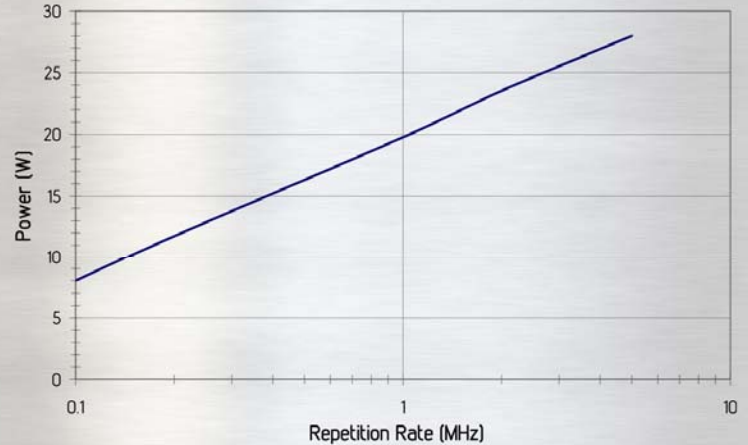
Control Systems

The system control computer allows users access and adjustment of the system features such as pulse width and repetition rate. Optional equipment is also software controlled.

Leopard Pulse Energy Low Rep Rate Operation



Leopard High Rep Rate Average Power CPA



Patent pending
 Thin disk technology under license from Stuttgart University
 Specifications subject to change

